

Interference Search

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	1	((lithographic or photolithographic or microlithographic or expos\$5) and (radiation or light or illumination) and (modulat\$3) and (wafer or substrate) and (accelerat\$3 or decelerat\$3) and scan\$4 and (speed or velocity)).clm.	US-PGPUB	OR	ON	2005/09/30 16:21

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9/30/05